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**INFORMATION DISCLOSURE STATEMENT
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Applicant: Theodorus H.J. BISSCHOPS

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Examiner: R. FULLER

Group Art Unit: 2851

U.S. PATENT DOCUMENTS

Examiner's Initials*		Document Number	Date MM/YYYY	Name (Family Name of First Inventor)	Class	Sub Class	Filing Date (if appropriate)
PT	AR	4,484,074	11/1984	Eder			
PT	BR	4,916,322	04/1990	Glavish et al.			
PT	CR	5,229,872	07/1993	Mumola			
PT	DR	5,260,151	11/1993	Berger et al.			
PT	ER	5,296,891	03/1994	Vogt et al.			
PT	FR	5,523,193	06/1996	Nelson			
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PT	IR	6,046,792	04/2000	Van Der Werf et al.			
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FOREIGN PATENT DOCUMENTS

		Document Number	Date MM/YYYY	Country	Inventor Name		Abstract		Readily Available	
							Enclosed	No	Enclose	No
PT	OR	WO 98/40791	07/2001	Europe	Van der Schoot					
PT	PR	EP 0965888	12/1999	Europe	Bleeker					
PT	QR	0 532 968 A1	03/1993	Europe	Moriyama et al.					
PT	RR	0 844 532 A2	05/1998	Europe	Kamiya					
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	XR									

OTHER (Including in this order Author, Title, Periodical Name, Date, Pertinent Pages, etc.)

PT	YR	Murphy et al., "Synchrotron Radiation Sources and Condensers for Projection X-Ray Lithography," <i>Applied Optics</i> , Vol. 32, No. 24, 1993, pp. 6920-6929.				
	ZR					
	AAR					
	BBR					
	CCR					
	DDR					

Examiner

Date Considered:

9-7-04

*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.